

Nanonics MultiView 1500

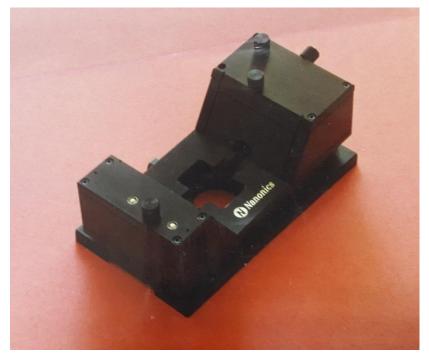
A Most
Versatile
Ultrasensitive
Scanning Probe
Microscope

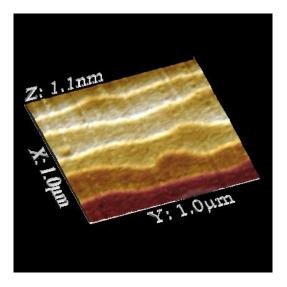


Patented UltraThin 3D Flat Scanners™



The Next Evolution In NanoCharacterization™





Atomic Steps Strontium Titanate



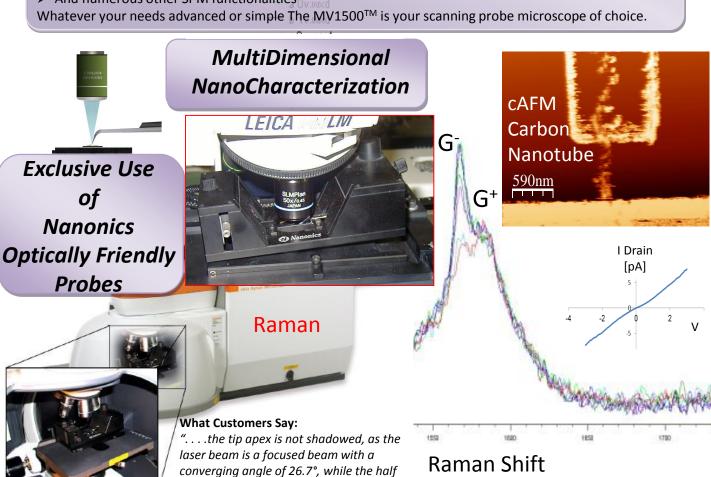
Ultrasensitive Compact Flexible Scanning Probe Microscope Providing The Ultimate In SPM Imaging & Harnessing New Horizons

The MultiView 1500TM is a compact ultra-low noise scanning probe microscope offering the highest of resolution and force sensitivity. It offers all modes of AFM, contact, tapping, non-contact and elasticity mapping together with other standard protocols. The MV 1500TM has the ultimate in flexibility for full optical integration with a variety of microscopes including Raman and Fluorescence. Unlike any other AFM it can be placed on the stage of any upright microscope for viewing opaque samples with the highest numerical aperture objectives. Furthermore, the system is completely unimpeded from below allowing for ease of integrating inverted and dual microscopes, magnets etc. Besides the ability to use all AFM probes available today, owners of the MV1500TM have exclusive use of Nanonics NanoToolKitTM of probes that permit a full range of functional SPM applications without obstructing the optical axis from above. This allows for on-line spectral characterization of chemical information using Raman, fluorescence or other spectral techniques. Functional SPM imaging available with such optically friendly probes include:

- Conductive AFM (cAFM)
- ➤ MFM/EFM
- > Thermal Conductivity (SThM)
- Near-field scanning optical microscopy (NSOM)
- Nanochemical Drawing with Fountain Pen Nanolithography (FPN)

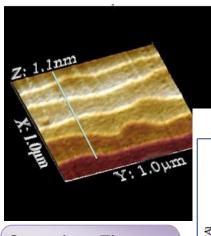
angle of the tip is only about 4°.

- Scanning Electrochemical Microscopy (SECM)
- And numerous other SPM functionalities





UltraLow Noise In X, Y And Z

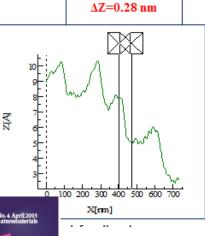


Strontium Titanate **Atomic Steps**

nature

matei

From The Ultra Small To The Ultra Large



Excellence In Nearfield Scanning Optical Microscopy (NSOM) & Super-resolution **Optics**

> **NSOM Live MDCK Cells**

> > **Stained** Cilium 8.0um

Q Dot Decorated DNA 110nm

Z: 67.5 µm Tip of A Razor Blade

> Unprecedented 85µm Z Range For Studying **Real Samples**

AFM

Live Cell NSOM **Nanophotonics** Possible For The First Time

Energy transfer in nanoparticle waveguides

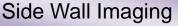
Antifouling layers

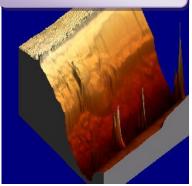
Hydrogen-induced metallization

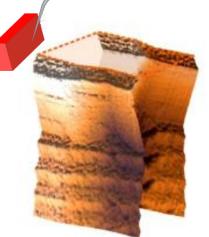
The NanoPhotonics System of Choice For The Last Two Decades



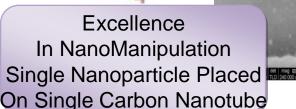
A Sampling of SPM Applications With The MV 1500TM

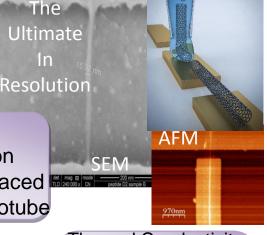




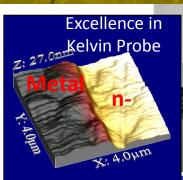


Writing Aligned Carbon
Nanotubes, DNA &
Conducting Metallic
Lines From Solution



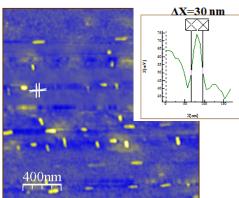


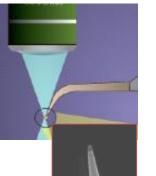
Thermal Conductivity Imaging Voids In Silicon

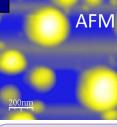


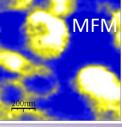
580nm











Imaging Magnetic Cobalt Particles
Placed Between Grating Lines With
Exclusive Single Magnetic
Nanoparticle Probes

Glove Box Ready



Specifications

AFM	Contact, non-contact, intermittent contact
AFM Feedback	 Optical Beam Bounce feedback: Contact mode, Intermittent (Resonant\Semi-Contact) mode The above modes can work in Normal and Lateral Force Magnitude and Phase Imaging Optional: Frequency Modulation Tuning Fork feedback with high Q factors and no optical feedback interference
Scanning Stage	 Piezo based flat scanning stage with central opening suitable for integration with optical microscopes with clear optical access uniquely from above for opaque samples and from below for inverted/dual microscopes, magnets etc
Scanning Modes	- Sample scanning
Scanning Range	Up to 85 microns in XYUp to 85 microns in Z
Scanner Resolution	- X and Y: 0.05nm, Z : 0.02nm
Z Imaging Noise	 0.05nm rms/ 0.2nm p-p obtained with AFM imaging of HOPG sample with atomic steps
Sample Size	 Up to 100mm in XY and 30mm in Z Large samples with odd geometries including allowing hanging of samples for cross section scans of edges
Sample Positioning	 Rough Scanning of 6 mm in XY using the same Fine Scanning Piezos controlled through AFM software and <1 nm positioning accuracy 85 micron XYZ positioning through Piezo offsets with accuracy of <1nm
Optical Viewing	 Clear optical access from above and below the sample without obscuration due to Cantilever or scanning stage. Optional Video Microscope: Dynamic magnification range 2.1–13.5X (full possible range: 0.09-393X) Field of View: 3 – 10 mm Optional Research Grade Microscope: Upright, Inverted and Dual Upright/Inverted optical microscope High NA objectives of 50x and 100x objectives including Water Immersion objectives. Suitable for sensitive optical measurements such as Confocal, Fluorescence,
	NSOM, etc Transparently integrated with Raman and other micro Spectroscopy systems
Vibration Isolation	Passive: - Vertical natural frequency of 1/2 Hz or less can be achieved over the entire load range - Horizontal natural frequency is load dependent. 1/2 Hz or less can be achieved at or near the upper limits of the payload range Active:
	- Also available

Controller	- Feedback speed of 4MHz
	- ADCs/DACs in 18 bit
	- 18 bit ADCs 4MHZ of sampling rate with 92 dB SFDR with various input ranges
	of +/-10V, +/-5V, +/-2.5V, +/-1.25V
	- X, Y, & Z High Voltage Amplifiers, Voltage output of ± 150v, 4 voltage display
	channels, Hardware slop compensation
	- 4 Digital inputs and outputs
	- 8 Analog inputs and outputs
Software	- Lab View based Software
	- Intuitive scan parameter setup
	- Real time processing of tilt removal and line normalization
	- Imaging and displaying 16 simultaneous channels
	- Zoom-in and offset scans
	- Inertial motion software interface for sample positioning
	- Z stepper motor interface for tip-sample approach
	- Extensive image processing options
	- Import data as Windows bitmaps and ACSII. Export data as TIFF and Windows
	bitmaps and ACSII
ScanControl Module	- Built-in module allows user to actively control the AFM scan for integration and
	synchronization with external instrumentation (such as Raman spectrometers,
	pulsed lasers, etc.)
	- Easy and intuitive graphical interface for specifying measurement points
	- Possibility of taking extra ADC measurements during scan
	 Possibility of sending triggers to external hardware during scan Possibility of running a user-defined Lab View VIs, allowing the user to perform
	any action or calculation during the scan
Imaging Modules	The MV1500 supports a multitude of SPM Imaging Techniques including standard
magnig Modules	techniques such as Force vs Distance curves and a variety of special options such as
	Electrical Imaging, Nano Indentation, Nanolithography, SECM, PFM, Thermal
	Lieutina, magnig, mano machadion, manoninography, Scott, Trivi, membra

Conductivity, Thermocouple Temperature Imaging, Kelvin Probe and other functional



The Next Evolution In NanoCharacterizationTM

imaging possibilities.

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